# M otion of C ontact Line of a C rystalO ver the Edge of Solid M ask in Epitaxial LateralO vergrow th 

M.K henner<br>D epartm ent of $M$ athem atics<br>State U niversity of N ew Y ork at Bu al<br>Bu alo,NY 14260<br>em ail: $m$ khenner@ nsm bu alo.edu

A pril 14, 2024


#### Abstract

M athem atical m odel that allow sfor direct tradking of the hom oepitaxial crystal grow th out of the window etched in the solid, pre-deposited layer on the substrate is described. The grow th is govemed by the nom al (to the crystal-vapor interface) ux from the vapor phase and by the interface di usion. Them odel accounts for possibly inhom ogeneous energy of the $m$ ask surface and for strong anisotropies of crystal-vapor interfacial energy and kinetic $m$ obility. Results dem onstrate that the $m$ otion of the crystalm ask contact line slow s dow $n$ abruptly as radius of curvature of the $m$ ask edge approaches zero. Num erical procedure is suggested to overcome di culties associated with ill-posedness of the evolution problem for the interface with strong energy an isotropy.

K eyw ords: Thin lm s, epitaxy, M OCVD, surface di usion, interface dynam ics, contact lines, rough surfaces, wetting, regularization of ill-posed evolution problem s.

PACS codes: 68.10.C r, $68.35 \mathrm{Ja}, 68.45 \mathrm{G}$ d, $68.55 . \mathrm{a}$, 81.10 A j .


## 1 Introduction

The Epitaxial Lateral O vergrow th (ELO) and Selective A rea Epitaxy (SAG) are com $m$ only used to grow micro-scale sem iconductor crystals and thin m s . Them icrom eter-scale selective grow th is well-achievable by chem ical vapor deposition or liquid phase eptaxy $\mid$ the ELO and SAG can be used also to grow nanostructures by the molecular beam epitaxy


Recently, the $m$ athem atical m odels that allow to num erically study the ELO and SAG
 els are formulated as free-boundary problem s in two dim ensions (that is, norm al to the
substrate/m ask and norm al to the axis of long stripe openings etched in the $m$ ask) and, therefore, they are capable of explicitly accounting for the $m$ ask topography and the interface anisotropy. The crystal grow th is by the norm al ux of particles from the vapor phase to the interface; the surface di usion redistributes the $m$ aterialalong the interface during the grow th. Evaporation-recondensation from both them ask surface and crystal-vapor interface, and the di usion of adatom s along the $m$ ask surface to the tri-junction crystal-m ask-vapor are accounted for by the m odels. The details of the form ulation, boundary conditions and num ericalm ethod can be found in $\left[\frac{0}{1}, 1,1,1\right.$. In this paper we only address issues related to the $m$ ask surface $m$ odeling and the crystal interaction $w$ th the edge of the $m$ ask ( $m$ ask comer point). N ote that the crystal grow th out of the trench occurs relatively early in the ELO
 the crystal-vapor interface by the edge of the $m$ ask exists for a long tim e after the actual interaction of the advancing edge of a crystal (contact line) and the m ask edge took place. $T$ hus it seem s im portant to understand the details of the contact line m otion over the edge.

In $\left[\begin{array}{l}{[\bar{\theta}, 1} \\ ,\end{array}, 1\right]$ ] the treatm ent of the contact line $m$ otion relies on the assum ptions of (a) the them odynam ic equilibrium at the tri-junction (indeed, SAG and ELO are equilibrium processes), (b) the $m$ ask surface as the rectangular, $m$ acroscopic step, and (c) the $m$ ask as the energetically hom ogeneous surface: the $m$ ask-vapor surface energy $m v=c o n s t: T$ he assum ptions (b) and (c) lim it the ability of any m odel to describe the overgrow th of the crystal line from the vertical onto the horizontal part of the $m$ ask. Indeed, (a) im plies that the equilibrium contact angle is given by the equation

$$
\begin{equation*}
\mathrm{mv} \quad \mathrm{am} \quad \mathrm{cv} \cos +\frac{@ \mathrm{cv}}{@} \sin =0 \text {; } \tag{1.1}
\end{equation*}
$$

where an and cv are the energies of the crystal-m ask and crystal-vapor interfaces, respectively (see A ppendix A). Then, (c) together w ith the natural assum ptions of constant (at the tri-junction) an and cv imply that is a constant value at the mask. H ow ever, due to (b) the $m$ ask edge is a singular point in the sense that the contact angle is not well de ned there. In $[\underline{\underline{9}}]$, this situation was dealt $w$ ith by instant readjustm ent of the interface $x$-axis angle (angle of the tangent, x) to a new value once the contact point reaches the $m$ ask edge to preserve the equilibrium constant angle. Such instant readjustm ent causes the short unphysical retraction of the contact point into the vapor phase and in uences the shape of the interface ${ }_{1}{ }_{1}{ }_{1}$. In this paper we $m$ ake an attem pt to $m$ odel the overgrow th event selfconsistently by approxim ating the $m$ ask edge by a circular arc and restricting the contact point to $m$ ovem ent along this arc. W e num erically study the lim it of zero arc radius. Since in applications the $m$ ask is often a crystalline solid itself, we allow for the anisotropy of mv and thus, by virtue of ( $\left.\overline{1} \bar{I}^{\prime} \mathbf{I}\right)$, for the variable along the m ask. (Q uartz or tungsten m asks


[^0]$w$ here $s$ is the arc length along the curve (crystal-vapor interface).
in the crystalline G aA s or sapphire substrate itself [ilin, 1 left on a surface of a substrate in this latter case are m ore advantageous for the epitaxy of som e sem ioonductor $m$ aterials than the geom etrically equivalent $m$ esas of the foreign (to the substrate) $m$ ask $m$ aterial.)

A part from the interest to this problem that stem $s$ from the ELO technology, there is a broad class of phenom ena in which the $m$ aterial-defect interaction is a key com ponent. For instance, when liquid wets the microsoopically rough surface the contact line gets pinned on surface asperities and thus becom es unstable. The latter problem, both for a single asperity and for the random ensemble of asperities has been studied intensively from a physioo$m$ echanical standpoint; see, for instance, recent works [1] $\overline{1}, 1 \overline{1} \overline{4}]$ and the review article by de $G$ ennes $[1$ organized structure was considered, for exam ple, by $O$ liver et al. in [i] defect is the edge of a solid disk that supports the liquid drop on its top. The pinning e ect of the edge has been exam ined theoretically and G ibbs inequality condition for the equilibrium of a drop bound by the edge has been con m ed experim entally. A lso, the various conditions for drop stability at the edge have been exam ined. A uthors used a circular sapphire disk w ith the 90 edge and the alum inum disks w ith the edges subtending a range of angles. In [ī귝, the nite elem ent stability analysis of an inclined pendant drop was perform ed, as well as the experim ent. The latter showed that both the contact line and the contact angle can adjust around the capillary until the Young-Laplace equation that balances the capillary pressure w ith pressure forces due to gravity [1] [1] is satis ed. In to the m odel of the contact line pinning on a single, $m$ acroscopic spherical defect $w$ as derived. H ow ever, our bibliography search for the study in whidh the direct num erical tradking of the contact linem otion over the defect is perform ed was unsuccessful. O bviously, the ELO problem for the hom oepitaxial crystal is sim pler than any sim ilar problem involving a liquid, since there is at least no need to solve the Young-Laplace equation. H eteroepitaxial and them al stresses, if present in a solid-on-solid system, m ay signi cantly com plicate the analysis, but they usually are incapable ofm odifying the equilibrium contact angle determ ined by the interfacialenergies alone [19] (how ever, as is well know $n$, they $m$ ay alter the dynam ics of the free surface of a solid m ). The latter in the case of the SAG was dem onstrated in [2] $20-1$, w here the $m$ orphologicalevolution of a heteroepitaxial thin m grow ing on a pattemed substrate was studied by the phase- eld $m$ ethod.

## 2 Form ulation

The Figure 'i-1 show s the problem geom etry. A s was already noted, the length of the open, unm asked stripes is assum ed much larger than their widths since large aspect ratios are com $m$ on in the applications; thus, the 2D crystal grow th $m$ odel can be used.


Figure 1: A sketch of the $m$ athem atical situation for the crystal grow th on the stripepattemed, $m$ asked substrate. The crystal-vapor interface is de ned param etrically as $y=$ $y(s ; t) ; x=x(s ; t) ; 0 \quad S \quad S(t)$, where $s$ is the arc length along the curve and $S$ is the total arc length of the curve. D ue to periodical arrangem ent of the stripes, the crystal grow th is studied on a partial cross-section which is a line segm ent extending from the center line of one $m$ ask surface at $x=$ ' to the œenter of the adjacent stripe at $x=L$. The interface is sketched such that the crystal overgrow th on the m ask is show n . T he mask is assum ed rectangular, w ith the rounded edge (solid curve; since the lateral length scale in the picture is much larger than the vertical one, the edge in the form of the circular arc does not look circular). is the angle that the outward unit norm al to the interface, $q_{c}, m$ akes with the horizontal axis. is the contact angle that the interface $m$ akes $w$ ith the $m$ ask surface, $m$ easured from w thin the crystal. is the angle that the unit nom al to the $m$ ask surface, $\mathrm{q}_{\mathrm{m}}, \mathrm{m}$ akes w ith the horizontalaxis. ( $\mathrm{x} ; \mathrm{y}$ ) is the contact point.

### 2.1 E quations of crystal grow th

B ased on the classicalM ullins' approach [1[2]i], the norm al velocity of the interface is form ulated as a function of the local curvature and its derivatives. In this work, we use

$$
\begin{equation*}
\mathrm{V}_{\mathrm{q}}=\mathrm{D}{\frac{\varrho^{2}}{\varrho \mathrm{~s}^{2}}}^{"} \hat{\mathrm{Cv}}()+{\frac{\varrho^{2} \hat{c v}()}{\varrho^{2}}}^{!} \mathrm{K}^{\#}+\mathrm{JM} \hat{M}() ; \tag{2.1}
\end{equation*}
$$

which is the simpli ed expression from ${ }_{6}^{\mathbf{Q}} \mathrm{T}$. W e neglect the evaporation-recondensation term as being unim portant for this study and assume the isotropic interfacial di usivity. The equation ( tive interfacial di usivity (see $T a b l e$ ?? in the A ppendix B), $K$ is the curvature and $J$ the com posite param eter that involves, in particular, the chem ical potential of the vapor phase and the $m$ ean value of the interface $m$ obility, $M o$ (the kinetic coe cient). ${ }^{\wedge}{ }_{\mathrm{cv}}($ ) and $\hat{M}()$ are the anisotropy factors of the interface energy and m obility, respectively. These factors are speci ed in Section '2. 2 '. The m arker particles on the interface are num erically advanced using the param etric evolution equations for the C artesian coordinates of particles, viz.

$$
\begin{align*}
& \frac{@ x}{@ t}=V_{q} \frac{@ y}{@ s} ;  \tag{22}\\
& \frac{@ y}{@ t}=V_{q} \frac{@ x}{@ s}:
\end{align*}
$$

$T$ hese equations are fourth-order parabolic when $\mathrm{V}_{\mathrm{q}}$ is given by (2.

### 2.2 M ask Energy and Shape

To derive the expression for $\mathrm{m} v$ which accounts for the additional edge energy, we use the $m$ ethod ofX in \& $W$ ong $[\underline{2} \overline{2} \overline{2}, \overline{2} \overline{2}]$, which they em ployed in $[\underline{2} \overline{-} \overline{4}]$ for studies of the grain boundary (G B ) grooving in polycrystalline thin m s . In contrast to the case of dynam ically evolving, faceted interfaces such as G B grooves, the application to the static crystalline m ask surface is straightforw ard since the $m$ ethod requires an a priori know ledge of facets orientations and lengths. D etails of the $m$ ethod can be found in $\left.\overline{\underline{2}} \bar{L}_{2}, 1 \overline{2} \overline{3} \overline{1}\right]$. For the rectangular crystal in the therm odynam ic equilibrium that represents the $m$ ask on a substrate (half of that crystal is shown in Fig. ( $\left.{ }^{1} 1,1, \overline{2}, 1\right)$, the result is the follow ing nondim ensional expression (units for the surface energy are chosen $m h_{m}=$, where is the atom ic volum e and $m$ is the equilibrium chem ical potential of the $m$ ask surface):

$$
m \mathrm{~m}=\mathrm{r}+\quad \mathrm{r}+2\left(\mathrm{r} \quad 9 \mathrm{~F} \quad \overline{2} \quad \cos +2\left(\begin{array}{ll}
1 & \mathrm{r})  \tag{2.3}\\
\frac{1}{2} & \mathrm{~F}(\quad) \sin ; 0
\end{array} \quad:\right.\right.
$$

In $\left(2 \underline{2}-\mathbf{x}_{1}\right), r=R=H$ is the ratio of the nondim ensionalcircular arc radius to the nondm ensional step height, ${ }^{\prime}=d=H$, where $d$ is the nondim ensional half-w idth of the $m$ ask, and $F(u)$ is Heaviside function (all lengths are nondim ensionalized by the half-w idth of the stripe, L). For our m odeling of the ELO, we are only interested in values of in [0; =2]. The function
 $m$ aximum at $==4$, since the halfm ask is taken square w th the rounded edge. The
sharper is the edge, the larger is the maxim um value. For the 90 edge $r$ is exactly zero, takes on values 0 and $=2$ only, and $\left(\underline{2}-\mathbf{N}_{2}\right)$ gives $\left.\mathrm{mv}(0)=\mathrm{mv}^{( }=2\right)=1$.


Figure 2: H alf of the $m$ ask w ith the rounded edge.


Figure 3: The nondim ensionalenergy of the $m$ ask surface as function of the angle of the unit norm al (to that surface), for the di erent ratios of the radius of the circular arc to the $m$ ask height. The points $(0 ; 1)$ and $(=2 ; 1)$ correspond to the vertical and horizontal parts of the $m$ ask, respectively; other points correspond to the circular arc that connects the vertical and horizontal parts.

To param etrize the $m$ ask surface, we take angle $\sim 2 \tilde{\sim}^{h} ; \sim_{2}+=2^{i}$ as the independent variable (see Fig. . $\overline{\text { ñ }}$ ). From geom etry,

$$
\begin{align*}
& \tilde{\sim}_{1}=\arctan \frac{H \quad R}{R}=\arctan \frac{1}{r} 1 ;  \tag{2.4}\\
& \tilde{\sim}_{2}=\arctan \frac{d \quad R}{R}=\arctan \frac{d}{R} 1:
\end{align*}
$$

Then,

A lso,
are the nondim ensional param etric functions that describe the $m$ ask surface. From (2. $\mathbf{L}_{1}^{\prime}$ )(2. $\bar{T}_{1}^{\prime}$ ), the rounded portion of the m ask is described by

$$
\begin{align*}
\left(x_{m}^{(a r c)}\right. & =R(1+\cos ) ; \\
y_{m}^{(a r c)} & =H \quad R(1 \quad \sin ) ; 0 \quad=\sim \quad=2: \tag{2.8}
\end{align*}
$$

Taking $m h_{m}=$ for the unit of $a n$, and (the $m$ ean value, see (2.1-1 below) for the unit of cv , the equation (

$$
\begin{equation*}
E(m v a m) \quad \hat{c v}() \cos +\frac{@_{\mathrm{cv}}}{@}() \sin =0 ; \tag{2.9}
\end{equation*}
$$

where $E=m h_{m}=(0), m v i s$ iven by (2), an now is the nondim ensional energy of the crystalm ask interface (assum ed constant and isotropic), $\wedge_{\mathrm{cv}}$ is the anisotropy factor of the interfacial energy, and is value of the angle of the norm al to the interface at the tri-junction. $N$ otioe that

$$
\begin{equation*}
=\quad+\quad: \tag{2.10}
\end{equation*}
$$

(2. $\underline{2}_{2}^{\prime}$ ) is solved once in the ${ }_{\mathrm{h}}$ beginning of the com putation and yields values of the im posed contact angle at every $\tilde{i}^{2} \quad \tilde{\sim}_{1} ; \tilde{2}_{2}+=2 ; i=1:: \mathbb{N} \sim$,where $N \sim$ is the num ber ofequidistant nodes in the interval. $N \sim$ is taken in the range 500 .. 3000, the larger the sm aller is the radius of the circular arc (since for the accurate $m$ arching of the contact point along the arc it is im portant to have su cient num ber of nodes there).

### 2.3 U pdating the contact point

In this section, the procedure which updates the position of the contact point on them ask is described. The update is needed after all $m$ arker particles on the interface but the contact point are $m$ oved one tim e step forw ard using the evolution equations (2,

Let $x$ and $y$ are the \old" coordinates of the contact point. $U$ sing $x ; y$, the coordinates
 rst com pute values of and at ( $x ; y$ ) by linear interpolation. $U$ sing the latter values, the angle of the tangent to the interface at ( $\mathrm{x} ; \mathrm{y}$ ) is found from

$$
\begin{equation*}
x=\quad+\quad=2: \tag{2.11}
\end{equation*}
$$

Let $\left(\mathrm{x}_{1} ; \mathrm{y}_{1}\right)$ and ( $\mathrm{x}_{2} ; \mathrm{y}_{2}$ ) are the coordinates of the rst twom arker particles on the interface closest to the contact point. In case the contact point is on the vertical part of the $m$ ask, the updated location is $(0 ; \hat{y})$, where

$$
\hat{y}=\frac{1}{3}\left(\begin{array}{ll}
4 y_{1} & y_{2}+\left(\begin{array}{ll}
x_{2} & 4 x_{1}
\end{array}\right) \tan x \tag{2.12}
\end{array}\right):
$$

This follow sfrom the second-order, one-sided nite di erence approxim ation of the contact angle condition (12'). In case the contact point is on the horizontal part of the $m$ ask, the updated location is ( $\hat{x}$; H ), where

$$
\begin{equation*}
\hat{x}=\frac{1}{3} \quad 4 x_{1} \quad x_{2}+\frac{3 H \quad 4 y_{1}+y_{2}}{\tan x}: \tag{2.13}
\end{equation*}
$$

In case the contact point is on the circular arc, we solve the quadratic equation (ref. $\left.(\overline{2} .)_{1}^{\prime}\right)$ )

$$
\begin{equation*}
\frac{1}{3}\left(4 y_{1} \quad y_{2}+\left(3 x \quad 4 x_{1}+x_{2}\right) \tan x\right)=H \quad R \quad 1 \quad q \frac{1}{1}(1+x=R)^{2} \tag{2.14}
\end{equation*}
$$

and nd two x -coordinates $\hat{x}^{(1)} ; \hat{x}^{(2)}$ and corresponding $y$-coordinates $\hat{y}^{(1)} ; \hat{y}^{(2)}$. Then, ifboth $\hat{\boldsymbol{x}}^{(1)} ; \hat{\boldsymbol{x}}^{(2)} \quad \mathrm{R}$ (that is, ifboth possible updated locations are on the arc), we take the pair of coordinates closest to ( $x ; y$ ) for the updated location. Ifonly one of $\left(\hat{x}^{(1)} ; \hat{y}^{(1)}\right)$; $\left(\hat{x}^{(2)} ; \hat{y}^{(2)}\right)$ is on the arc and the other is not, we choose the pair that is on the arc (closer to the \old" location).

### 2.4 A n isotropy

The anisotropy factor of the kinetic $m$ obility is chosen as in $\left.{ }_{2}{ }_{2}{ }^{5}\right]$, where the follow ing form is suggested and the sim ulations of faceted grow th are perform ed w thin the fram ew ork of phase eld bulk solidi cation model:

$$
\begin{equation*}
\hat{M}()=1+2 \tanh \frac{}{j \tan 2\left(+M_{j}\right) j} ; \quad M=M_{0} \hat{M}(): \tag{2.15}
\end{equation*}
$$

In (2.15), and are constant param eters that control the width and atness of facets, respectively; $m$ is the phase angle. Faœts are form ed at regions on the interface where $==4 \quad \mathrm{~m}+\mathrm{n}=2 ; \mathrm{n}=0 ; 1 ;::$. It was show n in $[\underline{[15}]$ ] that the results of com putationsw w th the four-fold anisotropy ( $\left.\overline{2} \cdot \overline{1} \overline{1}^{\prime}\right)$ are in good agreem ent w ith the so-called kinetic $W$ ul shapes (see references in [2] constructed and com pared to the experim ental shapes in [ַ̄q]). For the sim ulations discussed in the next section we chose $=0: 95 ;=2 ; \mathrm{m}=0$.

The anisotropy factor of the crystal-vapor interfacialenergy has standard, four-fold sym $m$ etric form

$$
\begin{equation*}
\hat{c v}()=1+\quad \cos [4(+)] ; \quad c \mathrm{cv}=\hat{0}_{\mathrm{cv}}() ; \tag{2.16}
\end{equation*}
$$

where the constant $>0$ determ ines the degree of anisotropy, and is the phase angle. In this work we allow for strong anisotropy of cv, e.g. $\quad>1=15$. In this case, the interface sti ness $G=\wedge_{c v}+@^{2} \wedge_{c v}=@^{2}$ is negative in certain intervals of values of , and that $m$ anifests in the appearance of comers on the equilibrium W ul shape of crystal $\left.\mathbb{R}_{2} \bar{\eta}_{1}\right] ;$ in the dynam ical case, the evolution equations becom e backw ard-parabolic and unstable where $\mathrm{G}<0$, see for exam ple

### 2.4.1 R egularization

To track interface evolution w ith the strongly anisotropic interfacialenergy, the problem m ust be regularized in order to penalize spatialoscillations as wellas the tendency to form comers. The regularization we use in this work is based on the addition of curvature dependence to
 shape; see [1]inj] for the $m$ odem $m$ athem atical analysis of this problem. A part from being usefiul as a m odeling tool, the regularization by curvature has physical ground, nam ely the
 other works where the ${ }^{2}$; = const: ( is the dim ensional curvature) term is added to the surface energy on the problem form ulation stage, here we regard the regularization only as a num erical technique intended to keep the com putation alive, and regularize by adding sam e term to cv given by $(\overline{2} \overline{1} \overline{\mathrm{G}})$ ) only at the distinct m om ents and only at the locations on the interface where the instability (tendency to form a comer) occurs. This is done as follow s.
$F$ irst, we continuously check the sign of $G$ at every $m$ arker location on the interface. Second, once at the certain location $G$ becom es negative (the comer has been form ed), we interrupt the com putation, restore all variables including the local interface shape and curvature to their previous states at positive $G$, add $K^{2} ;==\left({ }_{0} L^{2}\right)$ term to the nondi$m$ ensional interfacial energy ${ }^{{ }_{c v}}()$ at this location and solve the linear equation $G()=0$. $T$ he result,

$$
\begin{equation*}
=\frac{15 \cos [4(+\quad)] \quad 1}{\mathrm{~K}^{2}+2 \mathrm{~K} @^{2} \mathrm{~K}=@{ }^{2}+2(@ \mathrm{~K}=@)^{2}} ; \tag{2.17}
\end{equation*}
$$

is de ected by 0.1 to ensure positive $G$. The com putation is then restarted w ith the regularized cv; if needed, the procedure is repeated. This m ethod allow s to reduce the in uence of the regularization on interface shape to a minim um by (i) applying the regularization selectively and (ii) choosing value for the regularization constant no larger than needed to allow the com putation to proced. Them axim um value $10^{5}$ com es out from the com putation, which translates into $10^{11}$ erg; thus the additional comer energy necessary to regularize the problem is indeed very sm all

It m ust be noted here that the num ericalm ethod itself introduces som em inor sm oothing, since the interface is rem eshed every tim e step with the help of cubic splines [8] ${ }_{1}^{-1}$.

The regularization by curvature is not used at the contact point and its vicinity. Instead, to ensure stable tracking of the sensitive contact point $m$ otion over the $m$ ask edge in the sim ulations w ith strongly anisotropic surface energy, we had to resort to the $m$ ethod which is described in the next subsection.

### 2.4.2 C ontact point regu larization

W e take

$$
\begin{equation*}
={ }^{(0)}+\quad{ }^{(0)} \mathrm{H} \quad\left(\mathrm{~s} \quad \mathrm{~S}_{\mathrm{C}}\right) ; \tag{2.18}
\end{equation*}
$$

[^1]where ${ }^{(0)}$ is constant value takes on the interval of the arc length $0 \quad \mathrm{~s}<\mathrm{S}_{\mathrm{c}} \quad, \quad>{ }^{(0)}$ is constant value takes on the interval $S_{C}+<S \quad S$, and $H$ ( $s S_{C}$ ) is the sm oothed H eaviside function (see, for instance, $\left.\left[\frac{1}{3} 2 \overline{2}\right]\right)$, viz.

In (2. $2=$ donst: is the sm all halfw idth of the transition region from 0 to 1 around
 $s_{c}$ and $s_{c} \quad s \quad s_{c}+$ evolve $w$ ith lesser degree of anisotropy than the rem aining interval $\mathrm{s}_{\mathrm{c}}+<\mathrm{s}$ S. For instance, for the simulation shown in $F$ ig. ' ${ }_{-1}$, we chose
${ }^{(0)}=0: 01 ; \mathrm{s}_{\mathrm{c}}=0: 08 ;=0: 02$. Of course, such choice is di cult to justify physically, but nevertheless it allow s to perform sim ulations and obtain the right interface shape som e


## 3 R esults

Since the param eter space is very large, the overgrow th w as com puted for the separate cases of evolution w ith the anisotropic $m$ obility and crystal-vapor interfacial energy. W e studied the in uence of param eters $r$ and am. O ther param eters are xed at their values cited in Table ??.

### 3.1 O vergrow th $w$ ith an isotropic m obility

It is assum ed in this section that $=0$, thus ${ }_{\text {cv }} 1$ and the contact angle is determ ined from the equation ( $2 . . \mathrm{d}$ ) where the third term identically equals zero.

Fig. 'i'i (a) show s the overgrow th over the blunt edge $r=0: 5$ (the radius $=50 \mathrm{~nm}$ ) of the energetically inhom ogeneous m ask. A lso show $n$ in $F$ ig. 'íi (b) is the actual contact angle vs. . Value for am ischosen 100 ( $500 \mathrm{erg} / \mathrm{cm}^{2}$ ), so that ( ) > =28 (partial $\backslash w$ etting"). O ne of accuracy checks is the com parison every tim e step of the actual value of the contact angle w ith the im posed ( ) given by ${ }^{\prime}(\underline{2}-\overline{2})$. The di erence is negligible for all runs perform ed. $N$ otice that the perfectly straight facet is form ed in the direction 135 to the substrate. The feature ( $\backslash$ bum p ") is present at the junction of this facet and the horizontal, 90 facet. This bum $p$ is present on the surface even before the contact point reaches the $m$ ask edge, but the edge $m$ akes it $m$ ore pronounced. T he bum $p$ gradually disappears after the edge is passed.

$F$ igure 4: (a) The overgrow th over the blunt edge $r=0: 5$ of the energetically inhom ogeneous $m$ ask. D ashed curves show the interface at progressively increasing tim es. (b) The contact angle dependence on the angle of the norm al to the $m$ ask surface, for the crystal grow th show $n$ in (a).

Fig. ' $\bar{T}_{-1}(a, b)$ com pares the overgrow th over the shanper edge $r=0: 0125$ (the radius $=$ 125 nm ) of the energetically inhom ogeneous m ask as in F ig. ' 14.1 the edge of sam e sharpness of the energetically hom ogeneous mask. For the latter, value for the constant is taken the average of the $s m$ allest and largest values of in F ig. $\overline{\mathrm{n}} \mathrm{-}$ (b) ( = 1:956). The overgrow th over the energetically hom ogeneous $m$ ask is faster, and the bum $p$ is $m$ ore pronounced in this case. $N$ evertheless, the di erence in the overgrow th of the m ask edges of di erent energy is quite sm all.


Figure 5: (a) The overgrow th over the shanp edge $r=0: 0125$; dashed curve: ( ) as in $F$ ig. ', ī (b), dotted curve: = 1:956. (b) The enlarged view of the tri-junction region.

Fig. $i_{-1}^{-6}(a, b)$ com pares the overgrow th over the $r=0: 0125$ edge of the energetically
inhom ogeneous mask that supports di erent ( ) (that is, the dynam ics corresponding to
 the crystal thickness are larger for the less wetting case (larger 's) when the contact point slides over the m ask edge. H ow ever, im m ediately after the edge the overgrow th of the m ore wetting crystal is faster, but it slow s dow $n$ as the overgrow th on the m ask progresses. $T$ his is expected since $==2$ on the horizontalpart of the $m$ ask. Finally, the less wetting crystal takes over, but its thickness in the $y$-direction is less than one of the $m$ ore wetting crystal.


Figure 6: (a) The overgrow th over the shanp edge $r=0: 0125$; dashed curve: ( ) as in Fig. $\overline{4}$ (b) (less wetting), dotted curve: ( ) as in part (c) of this gure (m ore wetting). (b) The enlarged view of the tri-junction region. (c) The contact angle vs. . To obtain this dependence, value for $a m$ is chosen 0.1 ( $0.5 \mathrm{erg} / \mathrm{cm}^{2}$ ).

The distance from the contact point to the foot point $(0,0)$ of the $m$ ask vs. tim $e$ is show $n$ in $F$ ig. ${ }_{-1}^{17}(a, b)$ for the overgrow th over $r=0: 5$ and $r=0: 0125$ edge, respectively, and $\mathrm{am}=100$. For the blunt edge, the com putationaldata is tted wellby the cubic polynom ial and thus the speed of the contact point vs. time is the quadratic function that has the m inimum value $4 \quad 10^{4}(4 \mathrm{~nm} / \mathrm{s})$ at $t=125(6.3 \mathrm{~s})$ and the maxim um value $1: 4 \quad 10^{3}$ $(14 \mathrm{~nm} / \mathrm{s})$ at $t=50 ; 200(2.5,10 \mathrm{~s})$. For the sharp edge, the quadratic $t$ is better, and the
speed of the contact point is linear function of time (the min. value $\quad \begin{array}{lll}3: 25 & 10{ }^{4} & (3.25\end{array}$ $\mathrm{nm} / \mathrm{s})$ at $\mathrm{t}=100(5 \mathrm{~s})$, the max . value $5: 510^{4}(5.5 \mathrm{~nm} / \mathrm{s})$ at $\mathrm{t}=86(4.3 \mathrm{~s})$ ).


Figure 7: D istance vs. time (nondim ensional) from the tri-junction to the foot point $(0,0)$ of the $m$ ask for two values of the radius of curvature of the edge. (a) $r=0: 5$ (triangular sym bols) . (b) $r=0: 0125$ (square symbols). $F$ itting (solid curve) is for the time interval $w$ hen the contact point is on the circular arc of the $m$ ask.

This data, as well as $F$ igures $1 \overline{1} \uparrow \overline{1} \bar{\sigma}$ dem onstrate that de-pinning of the contact line of a crystal from the solid defect of nite size does not have a threshold nature; that is, the contact line is in constant $m$ otion over the defect, and the problem does not have a critical eigenvalue such that the contact line is pinned when som e param eter is sm aller than this eigenvalue and de-pinned ( $m$ oving) when the param eter is larger. In the language of $[1 \overline{15}]$, where the analogy between perturbed (on a defect) liquid contact line and an elastic spring is used to phenom enologically explain pinning (pages 836-38), the total pinning force exerted by the defect on the line is such that graphs of this foroe and the restoring linear elastic force (vs. position on a defect) are not intersecting, and thus there is no equilibrium, pinning line position (s) on a defect.

Finally, the average nondim ensional speed of the contact point's $m$ otion over the edge (naturally de ned as the length of the circular segm ent of the $m$ ask, $R=2$, divided by the traversal tim e) is plotted in Fig. 'ió vs. r. There is an evident tendency for pinning of the contact point at the edge as $r$ ! 0 . D ata can be satisfactory tted by a hyperbolic tangent curve (not shown). In the lim it $r=0$ (the $m$ athem atically sharp edge) the true pinning is expected (the speed $=0$ ). The contact line starts to actually \feel" the edge only when the latter has su ciently sm all radius of curvature ( $\mathrm{r} 0: 1 \quad 0: 15,10-15 \mathrm{~nm}$ ).


F igure 8: The average speed of the contact point's m otion over the mask edge.

N ote that despite such characteristic of the m otion of the contact line over the edge as the speed (instantaneous and average) is, of course, a function of all param eters of the system, the pinning on the edge as its radius of curvature approaches zero is the universal tendency. $T$ his was checked by $m$ eans of $m$ ultiple runs $w$ th di erent param eters. The com putation fails for r < 0:0075 (the radius< 0:75 nm ) because as the num ber of discretizing nodes along the $m$ ask increases, the nodes on the two straight segm ents of the $m$ ask com e too close to each other and the interpolation becom es inaccurate. In principle, the com putation w ith sm aller radii can be $m$ ade successfiul by using the nonuniform grid along the $m$ ask; we did not attem pt to do that. It is also doubtful that very shanp $m$ ask edges (having the radii of curvature of the order of a m olecule size ( $1-2 \mathrm{~nm}$ )) are achievable by the lithography, etching and polishing used in the ELO /SAG practice for the preparation of a $m$ ask. For com parison, the sapphire disks used for the late 1970s experim ents $w$ ith the liquid drops by 0 liver et al [ī]-1] had the edge radius of curvature sm aller than 50 nm , and $\backslash \mathrm{m} u \mathrm{uch}^{\mathrm{s}}$ aller" than that value if the defects (chipped-o hollow s) appear along the edge. T hese disks were prepared by cutting from a fused sapphire boule. The alum inum disks they used had very blunted edges w th the radius of curvature 1 to 5 m .

### 3.2 O vergrow th with strongly anisotropic cv

It is assum ed in this section that $=0$, thus $\hat{M} \quad 1$. The contact angle is determ ined from the equation (2.- $\overline{2})$, where the third term is nonzero due to the an isotropy in the crystal-vapor surface energy.

Fig. '9,-1 show S , as an exam ple, the overgrow th over the blunt edge $\mathrm{r}=0: 5$ (the contact
 is 0.07 . This is just above the critical value $1 / 15 .=0: 085 \mathrm{in} \mathrm{F}$ ig. ${ }^{\mathbf{j}} \mathrm{F}(\mathrm{b})$. For both gures, the value of the phase angle is chosen 1.67 (a little larger than $=2$ ).


Figure 9: (a) The overgrow th w ith the strongly anisotropic interfacialenergy over the blunt edge $r=0: 5$ ofthe energetically inhom ogeneousm ask. $=0: 07$. (b) Sam eas (a), $=0: 085$.

In Fig.
facet; other than that, the evolution resem bles the isotropic evolution [g]. In Fig. ' ${ }_{-1}$ (b), the interface instantly becom es unstable and the characteristic, coarsening with tim e hill-andvalley structure is form ed (bump) followed by the $=45$ inclined facet are again form ed. Thus this num erical experim ent suggests that the strong interfacialenergy anisotropy $m$ ay be one of the possible causes for the \bum py" crystal shapes routinely observed in ELO deposits [1], ,
 i' $\overline{1}\left(\mathrm{i}\right.$ (c), this function is not $m$ onotone. As ${ }^{(0)}$ increases quite beyond value 0.01 chosen for com putations in this section, the variations in becom em ore pronounced and the com putation becom es unstable.


Figure 10: The contact angle vs. for the interface evolution in $F$ igures ${ }^{\prime} 9(a, b)$.

A cknow ledgem ents
The author thanks P rofessors R idhard B raun (U niversity of D elaw are) and B rian Spencer (SUNY at Bu alo) for the stim ulating and usefuldiscussions of this work. The reviewer is acknow ledged for pointing out the relevance of H erring's equation to the problem considered in this work.

## A $O n$ equation (1.1:1)



$$
\begin{equation*}
{ }_{1} \cos _{2} \quad{ }_{3} \cos \sin _{3}+\frac{\varrho_{2}}{@_{2}} \sin 2+\frac{@_{3}}{@_{3}} \sin { }_{3}=0 \text { : } \tag{A.1}
\end{equation*}
$$



$$
\begin{equation*}
2 \operatorname{COS} 2=1 \quad 3 \tag{A2}
\end{equation*}
$$

to orientational dependence of surface energies (tensions) at the tri-junction (see Fig. 'iinil). To obtain (1, interface, the interface 2 w ith the crystal-vapor interface, the interface 3 w th the crystal$m$ ask interface and notice that $2^{2}$ and $3^{=} 0$ since the slope of the $m$ ask surface is everyw here continuous (F ig. 'ī2).


Figure 11: A sketch of the junction of three anisotropic interfaces, from [了ָ̄ī].

## B P aram eters of the $m$ odel (characteristic of epitaxy of G aA s-like sem iconductor at $\mathrm{T} \quad 650 \mathrm{C}$ )

This appendix has been rem oved from online subm ission to arX iv org in order to com ply w ith le size requirem ent; check the full version at
www m ath bu alo.edu/ m khenner.

## R eferences

[1] E.J.Thrush, JP.Stagg, M A. G ibbon, R E. M allard, B. H am ilton, J M . Jow ett, E M . A llen, M ater. Sci. and Eng. B 21 (1993) 130.
[2] M .G.M auk, J.P.Curran, J. C rystal G row th 225 (2001) 348.
[3] O.K . N am , T S. Zheleva, M D. . B rem ser, R F.D avis, J.E lectron. M ater. 27 (4) (1998) 233.
[4] J.E.G reenspan, X. Zhang, N.P uetz, B.Em m erstorfer, J. Vac. Sci. Technol. A 18 (2) (2000) 648.
[5] S .C . Lee, L R . D ow son, S R .J.B rueck, J. C ryst. G row th 240 (2002) 333339.
[6] Y. Yam azaki, J.H.Chang, M .W . Cho, T. Sekiguchi, T. Y ao, J. C ryst. G row th $214 / 215$ (2000) 202.
[7] X.M ei, M. B lum in, D.K im, Z. W u, H E. Ruda, J. C ryst. G row th 251 (2003) 253-257.
[8] M . K henner, R .J. B raun, M .G.M auk, J. C ryst. G row th 235 (2002) 425.
[9] M . K henner, R .J.B raun, M .G.M auk, J. C ryst. G row th 241 (2002) 330.
[10] M . K henner, \Enhancem ent of Epitaxial Lateral O vergrow th by VaporPhase D i usion", in press.
[11] R.N otzel, M.Ram steiner, J. M enniger, A. Tram pert, H .P. Schonherr, L . D averitz, K .H.P loog, J.A ppl. P hys. 80 (7) (1996) 4108-4111.
[12] Y P. H su, S.J.Chang, Y K . Su, J.K.Sheu, C.T.Lee, T.C.W en, L.W .W u, C.H.Kuo, C.S.Chang, S.C.Shei, J. C ryst. G row th 261 (2004) 466-470.
[13] D . Q uere, Physica A 313 (2002) 32-46.
[14] R.G olestan ian, E. R aphael, Phys. Rev. E 67 (2003) 031603.
[15] P.G.de Gennes, Rev. M odern Phys. 57 (3) (1985) 827.
[16] JF. O liver, C. H uh, S.G . M ason, J. C olloid Interface Sci. 59 (1977) 568-581.
[17] A . Laval, R A . B row n, J. C olloid Interface Sci. 89 (2) (1982) 332.
[18] S B .G . O ’B rien, J. C olloid Interface Sci. 183 (1996) 51-56.
[19] D .J. Srolovitz, S.H.D avis, A cta M ater. 49 (6) (2001) 1005-1007.
[20] J.J.E ggleston, P .W . Voorhees, A ppl. P hys. Lett. 80 (2) (2002) 306-308.
[21] W .W .M ullins, J.A ppl. Phys. 28 (3) (1957) 333.
[22] T. X in, H . W ong, Surf. Sci. Lett. 487 (2001) L529-L 533.
[23] T. X in, H.W ong, Technical Report M E M A 1-03, Lou isiana State U niversity (2003).
[24] T.X in, H . W ong, A cta M ater. 51 (2003) 2305-2317.
[25] T.U ehara, R F. Sekerka, J. C ryst. G row th 254 (2003) 251.
[26] S.H.Jones, L K . Seidel, K M . Lau, M . H arold, J. C ryst. G row th 108 (1991) 73.
[27] C. H erring, Phys. Rev. 82 (1951) 87.
[28] A.D iC arlo, M E.G urtin, P.Podio-G uidugli, S IA M J.A ppl. M ath. 52 (4) (1992) 1111-1119.
[29] A A. G olovin, S H. D avis, A A. N epom nyashchy, P hysica D 122 (1998) 202-230.
[30] T .V . Savina, A A. G olovin, S.H.D avis, A A. N epom nyashchy, P.W. Voorhees, Phys. Rev. E 67 (2003) 021606-16.
[31] B.J.Spencer, \A sym ptotic solutions for the equilibrium crystal shape w ith sm all corner energy regularization", in press.
[32] M . Sussm an, P. Sm ereka, S.O sher, J. C om put. Phys. 114 (1994) 146.
[33] Q uestion still rem ains whether it is possible to have the contact angle in the unstable range of angles and still $m$ ove along the $m$ ask, or just rem ain attached ( R .J.Braun, private com m unication).This di culty is physicalas well as $m$ athem atical. $W$ e plan to address th is issue in future publications.
[34] C.H erring, in Physics of P ow der M etallurgy, p.143.Ed.W E.K ingston, N Y , M CG raw fill 1951.


[^0]:    ${ }^{1}$ A ngle of the tangent is necessary for the determ ination of the location of the contact point on the $m$ ask by coordinate's extrapolation from $m$ arker particles adjacent to the contact point, through

    $$
    \begin{equation*}
    \tan \mathrm{x}=\frac{\mathrm{dy}=\mathrm{ds}}{\mathrm{dx}=\mathrm{ds}} \tag{12}
    \end{equation*}
    $$

[^1]:    ${ }^{2}$ In $\left[{ }^{2}{ }^{-1}{ }^{\prime}\right]$, param eter is introduced as the second partial derivative of the crystalline step energy w ith respect to the rst coordinate derivative of step density; this is di cult, if not im possible to extract from experim entaldata. W e are not aw are of a single experim ent there this or related quantity is m easured. Since value is unknow $n$, we think it $m$ akes sense to nd the suitable num ericalapproxim ation to the nondim ensional counterpart as explained.

